

TITLE: METHOD OF MANUFACTURING SURFACE ACOUSTIC WAVE DEVICE AND SEMICONDUCTOR DEVICE

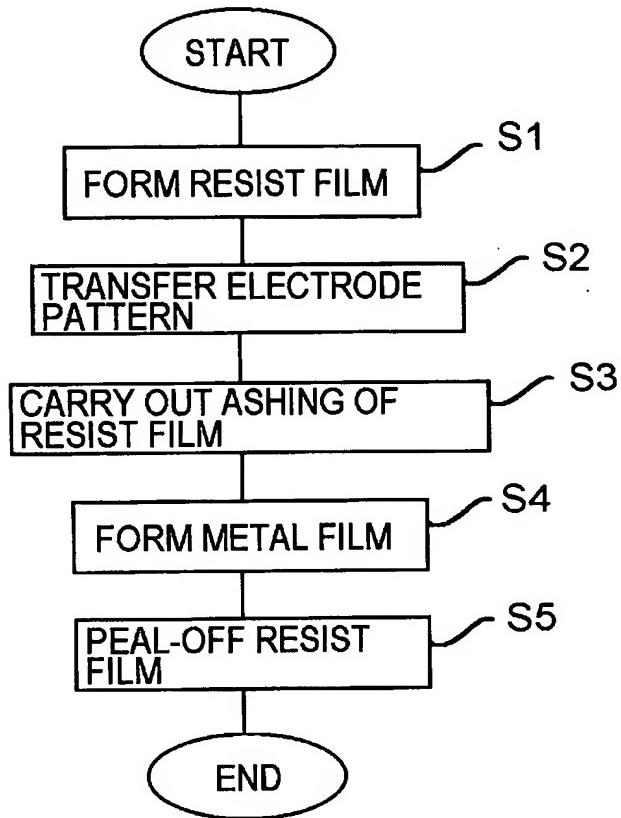


FIG. 1

FIG. 2A

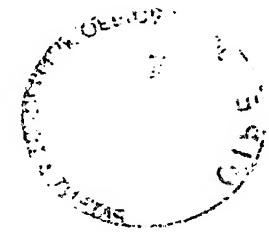
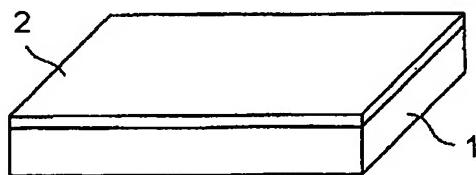


FIG. 2B

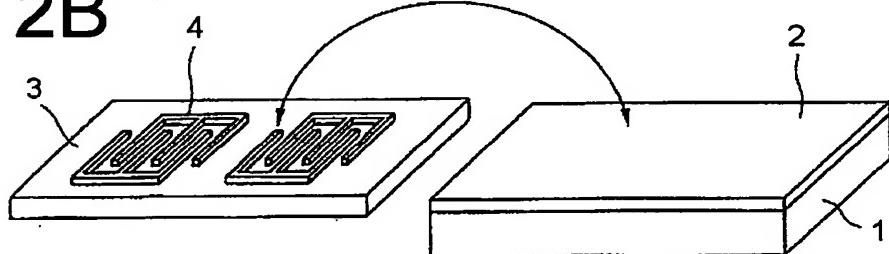


FIG. 2C

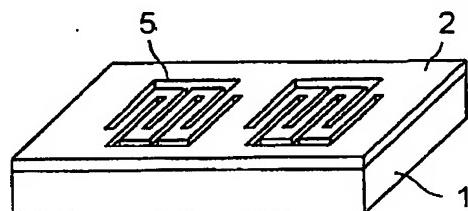


FIG. 2D

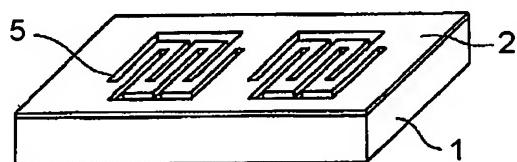


FIG. 2E

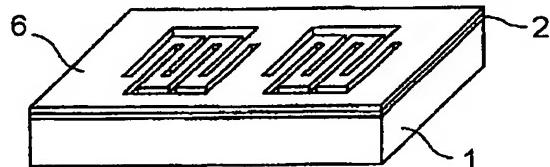


FIG. 2F

